# **Special Issue**

# Advances in Photodetecting Materials, Devices and Applications

## Message from the Guest Editor

Photodetection, which converts optical signals into electrical signals, is an irreplaceable source of information. Photodetectors with different response spectra have been used in various applications, such as imaging, communication, measurement, monitoring, etc. To meet the growing demand for higher figure-ofmerit parameters and new application scenarios, it is crucial to improve the performance of photodetectors through the development of new materials, novel device design, and exploration of new application. Accordingly, this Special Issue seeks to showcase research papers and review articles on (1) the methodology of synthesizing emerging photodetecting materials, e.g., perovskites, polymers, novel two-dimensional materials, and quantum dots; (2) photodetectors with novel structures, physics, and high figure-of-merit parameters; (3) demonstration of new applications of photodetectors. We look forward to receiving your submissions.

### **Guest Editor**

Dr. Zhanfeng Huang

School of Microelectronics Science and Technology, Sun Yat-sen University Zhuhai Campus, Zhuhai 519082, China

#### Deadline for manuscript submissions

closed (30 September 2024)



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Micromachines
Editorial Office
MDPI, Grosspeteranlage 5
4052 Basel, Switzerland
Tel: +41 61 683 77 34
micromachines@mdpi.com

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Impact Factor 3.0
CiteScore 6.0
Indexed in PubMed



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## Message from the Editor-in-Chief

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#### Editor-in-Chief

Prof. Dr. Ai-Qun Liu

Department of Electrical and Electronic Engineering, The Hong Kong Polytechnic University, Hong Kong, China

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